

**6.012 Microelectronic Devices and Circuits
Spring 2005**

March 9, 2005
Quiz #1

	<u>Problem #points</u>
NAME _____	1 _____
RECITATION TIME _____	2 _____
	3 _____
	Total _____

General guidelines (please read carefully before starting):

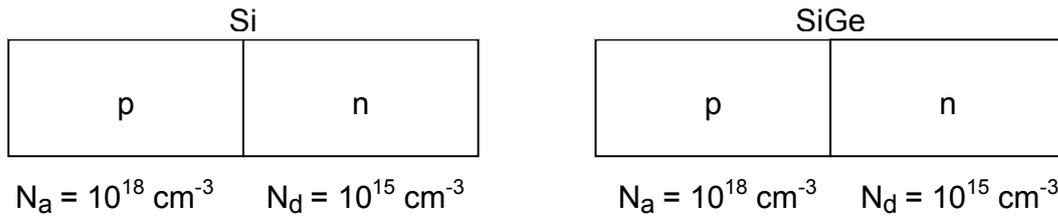
- Make sure to write your name on the space provided above.
- Open book: you can use any material you wish. But no computers.
- All answers should be given in the space provided. Please do not turn in any extra material.
- You have 120 minutes to complete the quiz.
- Make reasonable approximations and *state them*, i.e. low-level injection, extrinsic semiconductor, quasi-neutrality, etc.
- Partial credit will be given for setting up problems without calculations. NO credit will be given for answers without reasons.
- Use the symbols utilized in class for the various physical parameters, i.e. N_a , τ , ϵ , etc.
- Pay attention to problems in which *numerical answers* are expected. An algebraic answer will not accrue full points. Every numerical answer must have the proper *units* next to it. Points will be subtracted for answers without units or with wrong units. In situations with a defined axis, the *sign* of the result is also part of the answer.

Unless otherwise stated, use:

$$\begin{aligned}q &= 1.6 \times 10^{-19} \text{ C} \\kT/q &= 25 \text{ mV at room temperature} \\n_i &= 10^{10} \text{ cm}^{-3} \text{ for silicon at room temperature} \\\epsilon_{\text{si}} &= 10^{-12} \text{ F/cm} \quad \epsilon_{\text{ox}} = 3.45 \times 10^{-13} \text{ F/cm}\end{aligned}$$

1. (30 points)

Consider two pn-junction diodes that have identical uniform doping profiles, but differ in substrate – one is made of silicon, and one is made of a silicon-germanium alloy (SiGe). Assume the intrinsic carrier concentration for SiGe at room temperature is approximately 10^{13} cm^{-3} and $\epsilon_{\text{SiGe}} = 1.5 \times 10^{-12} \text{ F/cm}$



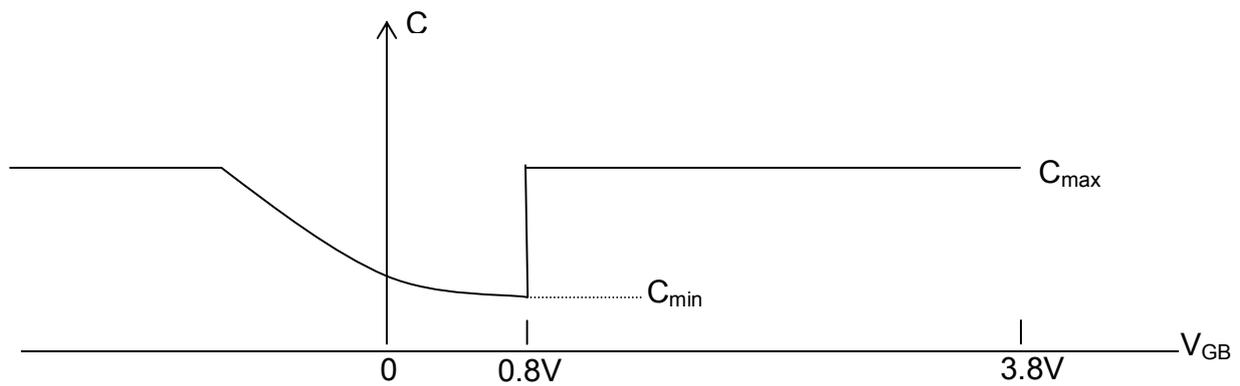
a) Calculate the built in potential for both the silicon and SiGe diodes.

b) Calculate the ratio of the depletion width on the n-side of the two diodes x_{no} in thermal equilibrium. [i.e. $x_{no}(\text{Si})/x_{no}(\text{SiGe})$]

c) Calculate the ratio of the electric fields at the metallurgical junction of the two diodes in thermal equilibrium. [i.e. $E_o(\text{Si})/E_o(\text{SiGe})$]

2. (35 Points)

An n^+ polysilicon gate ($N_d > 10^{20} \text{ cm}^{-3}$) MOS capacitor with p-type Si body has a capacitance-voltage plot shown below. The maximum capacitance per unit area $C_{\text{max}} = 1.7 \times 10^{-7} \text{ F/cm}^2$, while the minimum capacitance per unit area $C_{\text{min}} = 6.2 \times 10^{-8} \text{ F/cm}^2$. Assume $\phi_n^+ = 0.55 \text{ V}$.



a) What region of operation is the device in for $V_{\text{GB}} = 3.8\text{V}$?

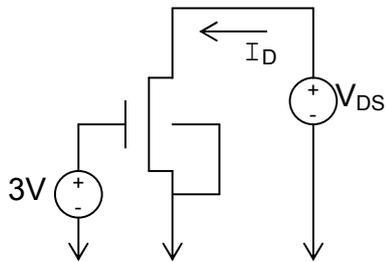
b) For the device in part (a), derive an expression for the depletion region width x_d at $V_{GB} = 3.8V$, in terms of C_{min} and C_{max} and fundamental parameters (e.g. q , ϵ_{ox} , ϵ_s , etc.)

c) For the device in part (a), if the magnitude of the gate charge $|Q_G| = 6.74 \times 10^{-7} \text{ C/cm}^2$, at $V_{GB} = 3.8V$, derive an expression for the doping N_a , in terms of C_{min} , C_{max} and other fundamental parameters.

- d) Calculate N_a from part (c) assuming $|Q_G| = 6.74 \times 10^{-7} \text{ C/cm}^2$ and the other parameters given in (a) above:

3. (35 points)

You are given an MOS transistor with the device parameters shown below.



$$\begin{aligned} W &= 10\mu\text{m} \\ C_{\text{OX}} &= 10^{-7} \text{ F/cm}^2 \\ \mu_n &= 200 \text{ cm}^2/\text{V-s} \\ V_{\text{Tn}} &= 1\text{V} \end{aligned}$$

A drain-to-source voltage is applied resulting in the electric field at the source $E_y(0) = -3.75 \times 10^3 \text{ V/cm}$ and at the drain $E_y(L) = -7.5 \times 10^3 \text{ V/cm}$

a) Calculate I_D .

b) Calculate the V_{DS} applied.

c) Calculate the channel length L of this device.

d) What region of operation is the transistor biased? (Circle one and explain.)

Cutoff Triode Saturation

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